

U.S. PATENT DOCUMENTS

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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

WK	AN	Rauschenbach et al., "Formation of Compounds by Nitrogen Ion Implantation in Iron," Physica Status Solids (a), vol. 80, No. 8, Nov. 16, 1983, pp. 211-222 (12 pages)				
i~	AO	"Magnetic Micropatterning of FeNi/Fe/MN Exchange Bias Bi-Layers by Ion Irradiation," Journal of Applied Physics, Vol. 89, No. 11, June 2001, pp. 6606-6608				
	AP					
EXAMIN	NER:	DATE CONSIDERED: 240				
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